## In Situ Characterization of the Surface Reaction between Chemisorbed Ammonia and Oxygen on **Pt**{100}

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As the first step in the industrial synthesis of nitric acid, ammonia is oxidized over platinum to form NO.<sup>1,2</sup> This reaction, known as the Ostwald reaction, is biphasic, N2 being the major product at surface temperatures below 600 K, whereas NO is formed at higher temperatures. At the high temperatures used industrially the platinum catalyst is lost at a fairly steady rate as PtO<sub>2</sub>(g), which necessitates its regular replacement. Temperatureprogrammed reflection-absorption infrared spectroscopy, with simultaneous gas product analysis, has been employed here to provide the first in situ characterization of the surface reaction on Pt between preadsorbed O and NH<sub>3</sub>, at temperatures between 150 and 600 K. The results demonstrate that the reaction selectivity between NO and  $N_2$  is determined by the O adatom coverage.

The reaction was studied over polycrystalline Pt wire by Ya et al.<sup>3</sup> using secondary ion mass spectrometry. They found no evidence for surface intermediates and proposed a simple bimolecular reaction step to form NO; the formation of N2 was attributed to the reaction between adsorbed NO and NH<sub>3</sub>. The reaction was subsequently studied over polycrystalline wires<sup>4-6</sup> and Pt single-crystal surfaces,7,8 with no alteration to the conclusions of Ya et al.<sup>3</sup> However, recent work on the reaction over  $Pt\{111\}$  and polycrystalline  $Pt^{9-11}$  has led to a consideration of an N + O  $\rightarrow$  NO recombination and the NH + O  $\rightarrow$  NO + H exchange reactions, with gaseous N2 being formed by N atom recombination.

Recently Bradley, Hopkinson and King,12 hereafter BHK, performed an exhaustive molecular beam study of the reaction and deduced a new mechanism invoking O adatom coverage as the critical factor in determining if NO or N<sub>2</sub> is the major gaseous product. The following are the major ingredients of the BHK model, after initial stripping of adsorbed NH<sub>3</sub> to NH(a) by oxygen:

$$NH(a) + 2O(a) \rightarrow NO(a) + OH(a)$$
(1)

$$NO(a) \rightarrow NO(g), \quad \theta_0 > 0.2 \text{ ML}$$
 (2)

 $NO(a) \rightarrow N(a) + O(a), \quad \theta_0 < 0.2 \text{ ML}$ (3)

$$2N(a) \rightarrow N_2(g) \tag{4}$$

Step 1 is dominant at relatively high O coverages ( $\theta_0$ ). Step 2 is favored if the oxygen adatom coverage is maintained above a critical coverage  $\theta_{\rm C} = 0.2$  monolayers (ML), while steps 3 and 4 dominate at low oxygen coverage. Thus, product selectivity in

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Figure 1. TP-RAIR spectra for the adsorption of 0.63 ML oxygen on Pt{100} at 300 K followed by 0.5 ML NH<sub>3</sub> at 150 K. The spectra were obtained at a heating rate of 1 K s<sup>-1</sup>.

this model is determined by the steady-state oxygen adatom coverage on the surface. BHK also concluded that step 3 is thermodynamically, not kinetically, prohibited at higher oxygen coverages due to the low heat of NO dissociative adsorption at high oxygen coverages.<sup>13,14</sup> In the present work we provide a critical test of the BHK model by monitoring the generation and consumption of chemisorbed molecular species formed during the reaction by reflection-absorption infrared spectroscopy (RAIRS) and by correlating this with the gaseous products.

The experiments were conducted in a uhv chamber with a base pressure of  $2 \times 10^{-10}$  mbar and interfaced via KBr windows to a Mattson RS-2 FTIR spectrometer.<sup>15</sup> The crystal preparation, including the formation of the stable hex and the metastable  $(1 \times 1)$  Pt{100} surfaces, has been described elsewhere.<sup>16</sup> Sharp LEED patterns were obtained with low background intensity. A time-resolved data acquisition program was employed to obtain temperature-programmed RAIR spectra at a heating rate of 1 K  $s^{-1}$  and a temperature resolution of 2 K spectrum<sup>-1</sup>.

To follow the surface reaction between adsorbed NH<sub>3</sub> and O adatoms, oxygen was preadsorbed on the  $Pt\{100\}$  (1  $\times$  1) surface at 300 K (to ensure dissociation to O adatoms) to coverages between 0.13 and 0.63 ML, and the surface was cooled to 150 K and dosed with 0.5 ML ammonia. These coverages were determined by reference to earlier sticking probability measurements.<sup>17,18</sup> The surface was then heated at 1 K s<sup>-1</sup> to obtain TP-RAIR and TPD spectra.

The infrared results obtained with 0.63 ML O predosed are shown in Figure 1. A single infrared band at 1618 cm<sup>-1</sup> grows into the spectra at 280 to 330 K, and is subsequently attenuated between 420 and 500 K. The band is readily assigned to the N-O stretch of adsorbed NO. In an independent experiment NO was adsorbed on the surface, and a band observed at 1599 to 1645

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**Figure 2.** TPD spectra for  $O_2$ ,  $N_2$  and NO from the adsorption of 0.63 ML oxygen on Pt{100} at 300 K followed by 0.5 ML NH<sub>3</sub> at 150 K. The integrated intensity of the NO band in the corresponding TP-RAIR spectra is also shown. The data were obtained at a heating rate of 1 K s<sup>-1</sup>.

 $cm^{-1}$ , dependent on coverage. By comparison of integrated intensities we estimate the maximum surface coverage of NO in the present experiment to be 0.32 ML. Two-thirds of the ammonia adsorbed has been converted to adsorbed NO.

In Figure 2 we show the TPD spectra for NO, N<sub>2</sub> and O<sub>2</sub>, together with the TP-RAIRS data now presented as integrated NO band intensity vs temperature. The attenuation of the infrared signal from adsorbed NO is correlated with the TPD peaks for NO and N<sub>2</sub> at  $\sim$ 470 K. We therefore reach two important conclusions from this comparison.

(i) Adsorbed NO formed in the surface reaction at 300 K partly desorbs as gaseous NO and partly dissociates at  ${\sim}470$  K, the N adatoms rapidly associating to form gaseous  $N_2.$ 

(ii) Since the NO coverage is stable between 330 and 430 K, the  $N_2$  TPD at 380 K is not derived from the surface NO formed. Similarly the  $N_2$  peak at 280 K, which appears before the appearance of NO(a), has an alternative origin. We assign these peaks to recombinative  $N_2$  formation resulting from the complete stripping of NH<sub>3</sub>(a) to N(a).

It now follows that, since N(a) recombinative desorption to  $N_2$  begins at ~210 K, well below the temperature at which NO rapidly forms (~310 K, Figure 1), the surface reaction to NO(a) proceeds via incompletely stripped NH(a), as in the BHK model, step 1. This reaction may be more properly considered as a two-step process:

$$NH(a) + O(a) \rightarrow HNO(a)$$
 (1a)

$$HNO(a) + O(a) \rightarrow NO(a) + OH(a)$$
 (1b)

Since the HNO(a) intermediate has not been observed, either in this or the earlier studies, we conclude that it is a very shortlived intermediate; reaction 1a is rate-determining.

The activation energy for the surface reaction to form NO(a), step 1, was estimated in a series of isothermal experiments between 270 and 300 K using time-resolved RAIRS to determine the rate of NO(a) formation. This yields an activation barrier of  $73 \pm 4 \text{ kJ mol}^{-1}$ , which is considerably smaller than the activation energy determined for the dissociation of NO adsorbed on Pt{100} and on polycrystalline Pt, of 120 kJ mol<sup>-1</sup>.<sup>19,20</sup> The surface reaction to form adsorbed NO occurs at a significantly lower temperature than that for NO dissociation.



Figure 3. Integrated intensity of the NO band observed in TP-RAIRS following the adsorption at 150 K of 0.5 ML  $NH_3$  on  $Pt\{100\}$  with oxygen precoverages of 0.63, 0.35, 0.21 and 0.13 ML.

For lower oxygen precoverages the TP-RAIRS and TPD data were quite different from the above. In Figure 3 we show samples of the TP-RAIRS data in the form of integrated N-O band intensity vs temperature plots. With oxygen precoverages of 0.21 ML and less, no surface NO could be detected. The preadsorbed oxygen is presumably consumed in stripping H atoms from NH<sub>3</sub>, and the only N-containing species observed in simultaneous TPD spectra is N<sub>2</sub>. At intermediate precoverages of oxygen, for example 0.35 ML, surface NO is again formed at ~300 K, but the band is now attenuated at temperatures above 310 K. This is the NO(a) dissociation reaction characterized by Fink et al.<sup>19</sup> and Pirug and Bonzel.<sup>20</sup> Again, in this coverage range no NO is observed in the gas phase: the NO formed in the surface reaction is quantitatively predissociated, the N adatoms combining to form gaseous N<sub>2</sub>. These results therefore provide direct confirmation of steps 2, 3 and 4 in the BHK model. When the O adatom coverage is high, the overall reaction proceeds to gaseous NO, but when the O coverage is low, NO formed in the surface reaction dissociates, leading to gaseous N2.

We note here that at the lowest O precoverage employed, 0.13 ML, a new infrared band was observed in TP-RAIRS. This band, at 1440 cm<sup>-1</sup>, first appears at ~220 K, is fully developed at 275 K, and is attenuated between 340 and 370 K. The attenuation is accompanied by N<sub>2</sub> desorption. The band is assigned to adsorbed NH<sub>2</sub>, based on the observation of the scissor mode for NH<sub>2</sub> on Pt{100} at 1450 cm<sup>-1</sup> in an HREELS study.<sup>21</sup>

We have demonstrated that the selectivity of the overall reaction between ammonia and oxygen to NO or to  $N_2$  on Pt{100} is controlled by the amount of oxygen adsorbed on the surface, in support of the BHK mechanism. At very low oxygen coverages adsorbed ammonia is stripped to NH<sub>2</sub>(a) which decomposes at  $\sim$ 350 K to form gaseous N<sub>2</sub>. At intermediate coverages adsorbed NO is formed in a surface reaction between NH and O, but the NO formed dissociates at a lower temperature ( $\sim$ 350 K) than that characteristic of NO desorption (~475 K), and the product is again gaseous N<sub>2</sub>. Above a critical steady-state coverage of oxygen, determined by BHK as 0.2 ML, NO dissociation is inhibited, and gaseous NO is therefore the main product of the reaction, at temperatures above  $\sim 470$  K. Under steady-state conditions, the selectivity of the reaction can therefore be controlled by varying the oxygen coverage. As concluded by BHK,12 high yields of NO can be obtained at low catalyst temperatures if the O<sub>2</sub>/NH<sub>3</sub> mix is kept O<sub>2</sub> rich.

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